

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 10/039,456  
 Priority Filing Date ..... December 31, 2001  
 Inventor ..... Ying Huang et al.  
 Assignee ..... Micron Technology, Inc.  
 Priority Group Art Unit ..... 2829  
 Priority Examiner ..... S.B. Geyer  
 Attorney's Docket No. .... MI22-2347  
 Title: An Improved Method, Structure and Process Flow to Reduce Line-Line  
 Capacitance with Low-K Material

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
 Commissioner for Patents  
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Sir:

This is a preliminary amendment accompanying a Request for Continuation Application for the above-entitled patent application. Prior to examining the application, please enter the following amendments.

**AMENDMENTS**

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.